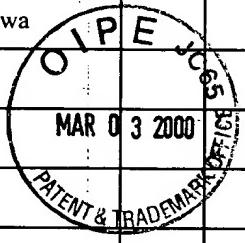


Form PTO-1449		ATTY DOCKET NO. 20-4652P	APPLICATION NO. 09/471,173			
<b>INFORMATION DISCLOSURE CITATION IN AN APPLICATION</b>  (Use several sheets if necessary)		APPLICANT Narihiro MOROSAWA et al.				
		FILING DATE December 22, 1999	GROUP Not Assigned			
<b>U.S. PATENT DOCUMENTS</b>						
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
<b>FOREIGN PATENT DOCUMENTS</b>						
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	TRANSLATION
						YES
<i>JZ</i>	HEI 5-082777 Japanese Patent Laid-Open Publication	4/2/93	JAPAN			ABST.
<i>JZ</i>	HEI 5-074762 Japanese Patent Laid-Open Publication	3/26/93	JAPAN			ABST.
<i>JZ</i>	HEI 5-283679 Japanese Patent Laid-Open Publication	10/29/93	JAPAN			ABST.
<b>OTHER DOCUMENTS</b> (Including Author, Title, Date, Pertinent Pages, etc.)						
<i>JZ</i>	“Effects of boron penetration and resultant limitations in ultra thin pure-oxide and nitrided-oxide gate-films”, Toyota Morimoto et al., <u>IEDM</u> , pp. 429-432, 1990.					
	“CMOS Technology Scaling, 0.1µm And Beyond”, Bijan Davari, <u>IEDM</u> , pp. 555-558, 1996.					
	“Analysis of an ONO gate film effect on n- and p-MOSFET mobilities”, H. Iwai et al., <u>1990 Symposium on VLSI Technology</u> , pp. 131-132.					
	“Hot-Electron Hardened Si-Gate MOSFET Utilizing F Implantation”, Yasuhiro Nishioka, et al., <u>IEEE Electron Device Letters</u> , Vo. 10, No. 4, pp. 141-143, April 1989.					
EXAMINER	<i>Kevin Quinto</i>	DATE CONSIDERED		<i>3/22/01</i>		
EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.						

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Sheet 1 of 1 (3-3-00)

Form PTO-1449		ATTY DOCKET NO. 20-4652P	APPLICATION NO. 09/471,173			
<b>INFORMATION DISCLOSURE CITATION IN AN APPLICATION</b>  (Use several sheets if necessary)		APPLICANT Narihiro MOROSAWA et al.				
		FILING DATE December 23, 1999	GROUP 2811			
<b>U.S. PATENT DOCUMENTS</b>						
EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
KL	6,018,182	01/25/2000	Morosawa			
<b>FOREIGN PATENT DOCUMENTS</b>						
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	TRANSLATION
						YES
<b>OTHER DOCUMENTS</b> (Including Author, Title, Date, Pertinent Pages, etc.)						
EXAMINER	Ken Qubis	DATE CONSIDERED				
		3/22/01				

EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

DJD:kna